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Attorney's Docket No.: 07977-093002 / US3164D1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Hisashi Ohtani, et al. Art Unit : 2815
Serial No. : 09/379,702 Examiner : Eugene Lee
Filed : August 24, 1999
Title : METHOD OF FABRICATING SEMICONDUCTOR DEVICES

Commissioner for Patents
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Dear Sir:

Applicants call attention to the attached Information
Disclosure Statement and documents listed on form PTO-1449.

Kindly accept this Information Disclosure Statement under
Rule 97(c)(2). The rule 17(p) certification fee of \$180 is
enclosed.

The documents are in the English language; hence no concise
explanation is necessary per Rule 98(a)(3).

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correspondence is being deposited with the
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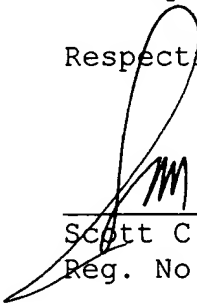
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Consideration of the foregoing and enclosures plus the return of a copy of the enclosed form PTO-1449 with the Examiner's initials in the left column per MPEP 609 are earnestly solicited along with an early action on the merits.

Respectfully submitted,

Date: _____

6/14/02



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